



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Batch/Confirmation No.: 5188

Yasuhiro OMURA et al.

Allowed: January 10, 2008

Group Art Unit: 2873

Application No.: 10/525,372

Examiner: M. HASAN

Filed: February 23, 2005

Docket No.: 122800

For: PROJECTION OPTICAL SYSTEM AND METHOD FOR
PHOTOLITHOGRAPHY AND EXPOSURE APPARATUS AND METHOD
USING SAME

LETTER TO THE OFFICIAL DRAFTSPERSON

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please substitute the attached 20 sheets of formal drawings depicting Figures 1-20 for
the corresponding drawings filed with the application.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

MAC:jls

Date: February 19, 2008

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